

Docket No. 03500.012395.1

## YOSHIHIKO FUKUMOTO

Application No.: 09/429,530

Filed: October 28, 1999

For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE

Examiner: V. Perez Ramos

Group Art Unit: 1765

Date: October 31, 2002

COMMISSIONER FOR PATENTS

Washington, D.C. 20231

v Sir:

Transmitted herewith is an amendment in the above-identified application.

X No additional fee is required.

The fee has been calculated as shown below

deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231 on (Date of Deposit)

Damond E. Vadnais, Reg no. 52,310

Name of Attorney for Applicant

Ort 31, 2002

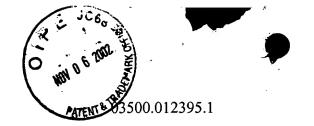
Signature Date of Signature

CLAIMS AS AMENDED								
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE		
TOTAL CLAIMS	12	MINUS	34	= 0	x \$9 \$18	.00		
INDEP. CLAIMS	3	MINUS	3	= 0	x \$42 \$84	.00		
Fee for Multiple Dependent claims \$140°/\$280								
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT								
○ Verified Statement claiming small entity status is enclosed, if not filed previously.  A check in the amount of \$ is enclosed.  Charge \$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.								

X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06 1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
	A check in the amount of \$ to cover the fee for a month extension is enclosed.
X	A check in the amount of \$\_180.00\] to cover the Information Disclosure Statement fee is enclosed.
X	Applicant's undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.
	Respectfully submitted,
•	Attorney for Applicant  Registration No

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3801 Facsimile: (212) 218-2200

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: YOSHIHIKO FUKUMOTO		Examiner: V. Perez Ramos  Group Art Unit: 1765		
Filed: October 28, 1999	)	TC P		
For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE	)	October 31, 2002		
Commissioner for Patents Washington, D.C. 20231		THE ROOM		

Sir:

In response to the Office Action dated July 31, 2002 (Paper No. 21), please amend the above-identified application, as follows:

**AMENDMENT** 

## IN THE CLAIMS:

Please cancel Claims 11 to 20, 25 to 27, 30 to 32 and 45 to 54 without prejudice or disclaimer of the subject matter presented therein and without conceding the correctness of their rejection. Please add new Claims 55 to 66 as follows:

deposited with the United States Postal Service as first class mail in an envelope addressed t : Commissioner of Patents and Trademarks, Washington, D.C. 20231 on (Date of Deposit)

Damond E. Vadnais, Reg no. 52,310

Name of Attorney for Applicant

Date of Signature

Date of Signature